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Docket No.: M-11021 US

JC580 U.S. Pro  
10/003908  
11/01/0112-06-01 A  
November 1, 2001Box Patent Application  
Commissioner For Patents  
Washington, D. C. 20231

Enclosed herewith for filing is a patent application, as follows:

Inventors: Entley, William R.; Langan, John G; Hall, Randy;

Title: In Situ Plasma Process To Remove Fluorine Residues From The Interior Surfaces Of A  
CVD Reactor

<u>X</u>	Return Receipt Postcard
<u>X</u>	This Transmittal Letter (in duplicate)
<u>15</u>	pages Specification(not including claims)
<u>3</u>	pages Claims
<u>1</u>	page Abstract
<u>4</u>	Sheets of Drawings
<u>3</u>	pages Declaration For Patent Application and Power of Attorney
<u>1</u>	page NonPublication Request
<u>1</u>	pages Recordation Form Cover Sheet (in duplicate)
<u>2</u>	pages Assignment
<u>1</u>	page Information Disclosure Statement
<u>1</u>	page PTO Form 1449 citing 7 references
<input checked="" type="checkbox"/>	Copies of 7 Cited References submitted

**CLAIMS AS FILED**

For	Number	Number	Basic Fee	
	Filed	Extra	Rate	
Total Claims	21	-20	=	\$ 740.00
		1	x	\$ 18.00 = \$ 18.00

Independent	1	-3	=	0	x	\$84.00	=	\$ 0.00
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Fee of \_\_\_\_\_ for the first filing of one or more multiple dependent claims per application \$

Fee for Request for Extension of Time \$

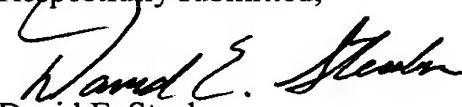
Please make the following charges to Deposit Account 19-2386:

Total fee for filing the patent application in the amount of \$ 758.00  
 The Commissioner is hereby authorized to charge any additional fees which may be required, or credit any overpayment to Deposit Account 19-2386.

EXPRESS MAIL LABEL NO:

EL901563767US

Respectfully submitted,

  
 David E. Steuber  
 Attorney for Applicants  
 Reg. No. 25,557

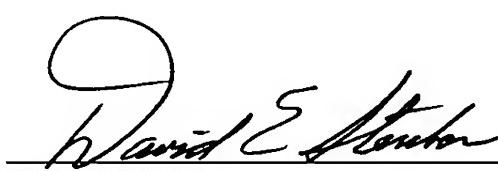
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MODIFIED PTO/SB/35 (11-00)

REQUEST AND CERTIFICATION UNDER 35 U.S.C. 122(b)(2)(B)(i)		Inventors	Entley, William R.; Langan, John G.; Hall, Randy
Title		In Situ Plasma Process To Remove Fluorine Residues From The Interior Surfaces Of A CVD Reactor	
Atty Docket Number		M-11021 US	

I hereby certify that the invention disclosed in the attached application has not and will not be the subject of an application filed in another country, or under a multilateral agreement, that requires publication at eighteen months after filing. I hereby request that the attached application not be published under 35 U.S.C. 122(b).

November 1, 2001  
Date



David E. Steuber  
Attorney for Applicants  
Reg. No.: 25,557

This request must be signed in compliance with 37 CFR 1.33(b) and submitted with the application **upon filing**.

Applicant may rescind this nonpublication request at any time. If applicant rescinds a request that an application not be published under 35 U.S.C. 122(b), the application will be scheduled for publication at eighteen months from the earliest claimed filing date for which a benefit is claimed.

If applicant subsequently files an application directed to the invention disclosed in the attached application in another country, or under a multilateral international agreement, that requires publication of applications eighteen months after filing, the applicant **must** notify the United States Patent and Trademark Office of such filing within forty-five (45) days after the date of the filing of such foreign or international application. **Failure to do so will result in abandonment of this application (35 U.S.C. 122(b)(2)(B)(iii)).**